



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 4, 2025

IGI Report Number **LG750577210**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **15.28 X 9.84 X 5.84 MM**

GRADING RESULTS

Carat Weight **5.58 CARATS**

Color Grade **F**

Clarity Grade **VS 1**

Cut Grade **EXCELLENT**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

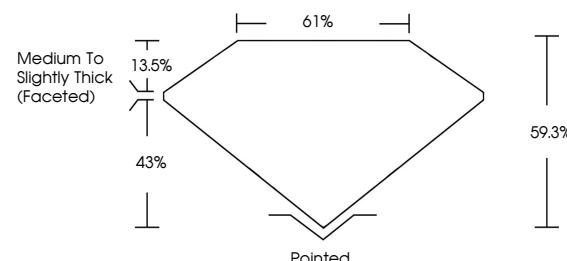
IGI LG750577210

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

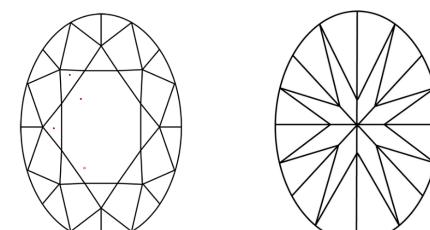
Type Ila

LG750577210
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

www.igi.org

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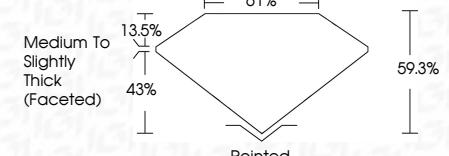
F

VS 1

EXCELLENT



Sample Image Used



ADDITIONAL GRADING INFORMATION

EXCELLENT

EXCELLENT

NONE

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December 4, 2025	IGI Report No LG750577210	OVAL BRILLIANT	5.58 CARATS	F	VS 1	EXCELLENT	59.3%	61%	Medium To Slightly Thick (Faceted)	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG750577210
Carat Weight	15.28 X 9.84 X 5.84 MM	Color Grade	Clarity Grade	Cut Grade	Depth	Table	Girdle	Fluorescence	Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.	Type Ila	Quiet	Polish	Symmetry	IGI LG750577210
Clarity Grade														
Cut Grade														
Depth														
Table														
Girdle														

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